

Electronic Acknowledgement Receipt

EFS ID:	1341351
Application Number:	10671813
International Application Number:	
Confirmation Number:	6832
Title of Invention:	METHOD FOR MINIMIZING SLIP LINE FAULTS ON A SEMICONDUCTOR WAFER SURFACE
First Named Inventor/Applicant Name:	Eric Neyret
Customer Number:	28765
Filer:	Jeffrey A. Wolfson/Stacy Jardim
Filer Authorized By:	Jeffrey A. Wolfson
Attorney Docket Number:	4717-7800
Receipt Date:	29-NOV-2006
Filing Date:	25-SEP-2003
Time Stamp:	16:48:52
Application Type:	Utility

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Certificate of Correction	4717-7800-certificateofcorrection.pdf	331021	no	5

Warnings:

Information:**Total Files Size (in bytes):**

331021

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.